

AMENDMENTS TO THE SPECIFICATION:

Please amend the paragraph inserted before the last paragraph on page 7, by the
Amendment filed November 5, 2003, as follows:

~~On the other hand, the hydrogen diffusion for removing a dangling bond is required in the surface of the photodiode 47. So, the~~ The dielectric layer 53 containing the hydrogen can be preferably formed above only upper portion of the photodiode 47.